

## . IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Mamoru NAKASUJI et al.

Group Art Unit: 2881

Serial No.: 10/766,041

Examiner: Phillip A. Johnston

Filed: January 29, 2004

Confirmation No.: 2576

For:

**APPARATUS** AND **METHOD** BEAM **ELECTRON** MANUFACTURING SEMICONDUCTOR DEVICE USING THE

**APPARATUS** 

Attorney Docket Number: 011470A

Customer Number: 38834

## AMENDMENT AFTER FINAL REJECTION

Mail Stop AF

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

Sir:

This paper is filed in response to the Office Action dated April 5, 2005.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 14 of this paper.